

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re DIVISIONAL Application of)
Shunpei YAMAZAKI et al.)
Based On Serial No. 09/932,935) Art Unit: 2812
Which Was Filed: August 21, 2000) Examiner: V. Simkovic
For: LASER APPARATUS, LASER)
ANNEALING METHOD, AND)
MANUFACTURING METHOD)
OF A SEMICONDUCTOR DEVICE) Date: November 9, 2001



INFORMATION DISCLOSURE STATEMENT


Honorable Commissioner for Patents and Trademarks
Washington, D.C. 20231

Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the references listed on the attached Form PTO-1449 be made of record in the above-identified application.

The references listed on the attached Form PTO-1449 were cited in parent application Serial No. 09/932,935 filed August 21, 2000, and predecessor application Serial No. 09/635,422.

Respectfully submitted,


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